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PRIOR ART

FIG.1A

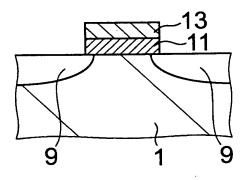


FIG.1B

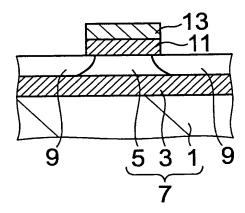


FIG.1C

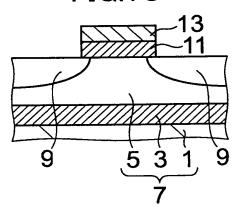
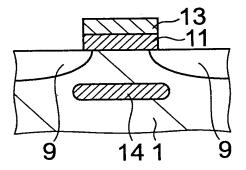
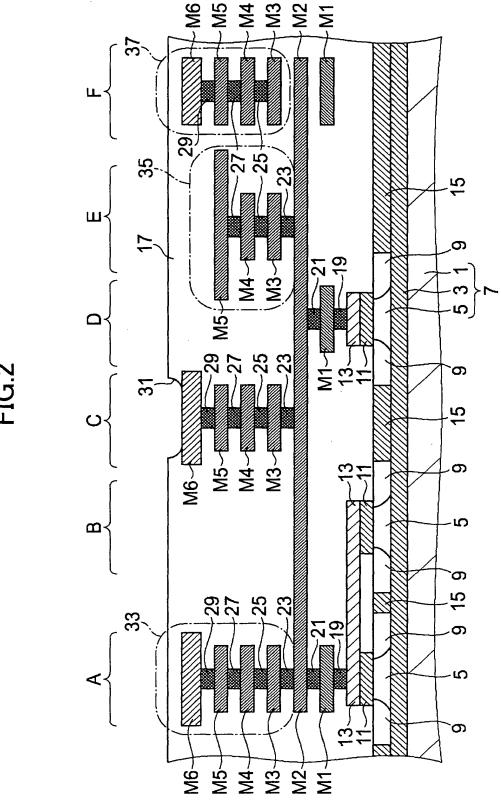


FIG.1D

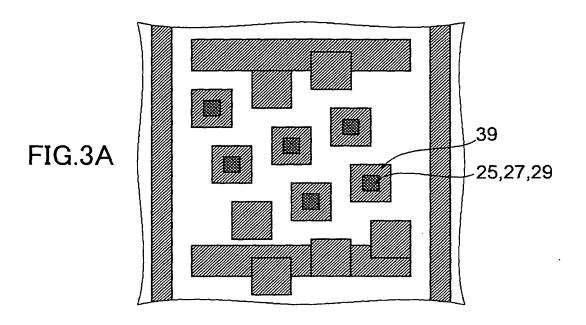


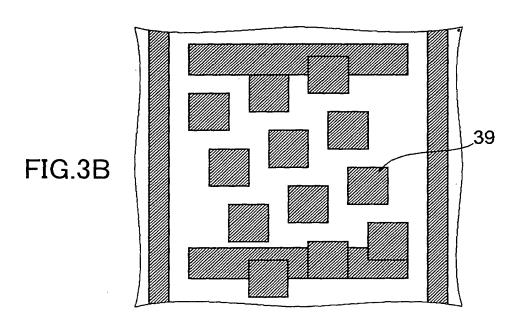
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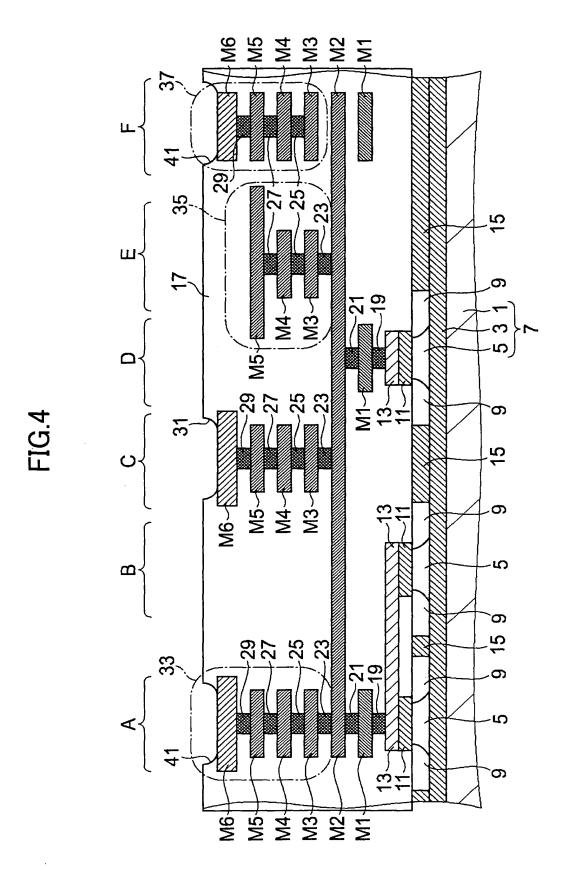




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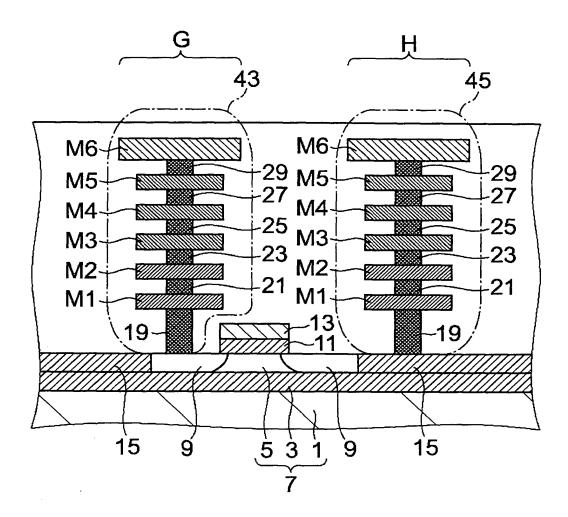


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FIG.5



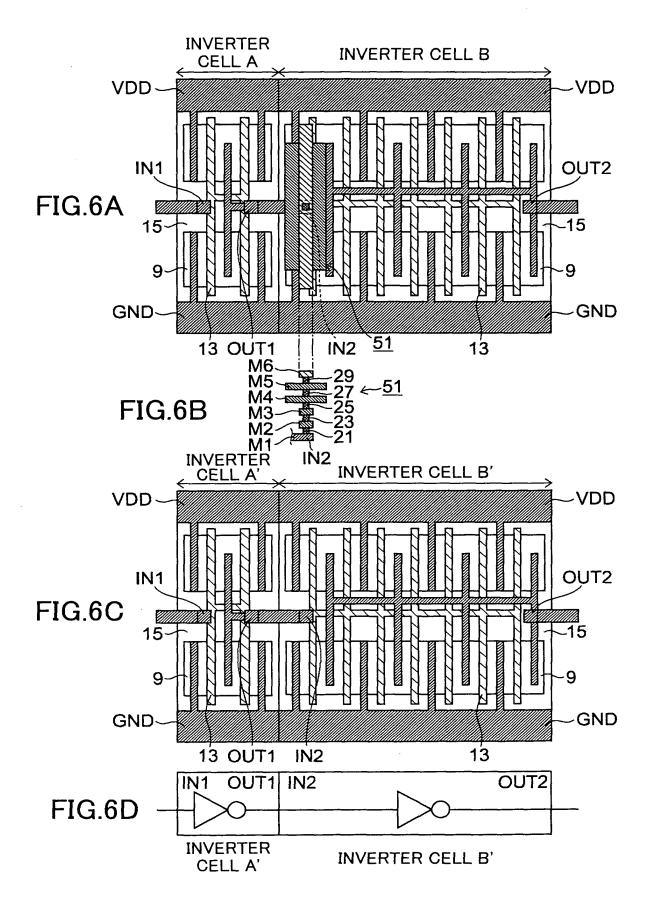
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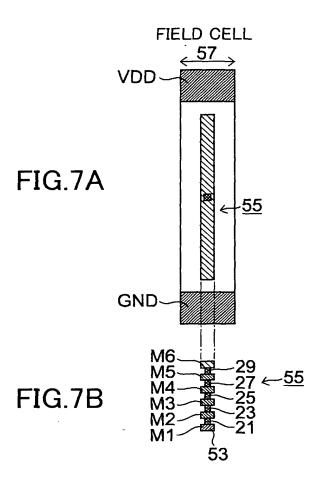
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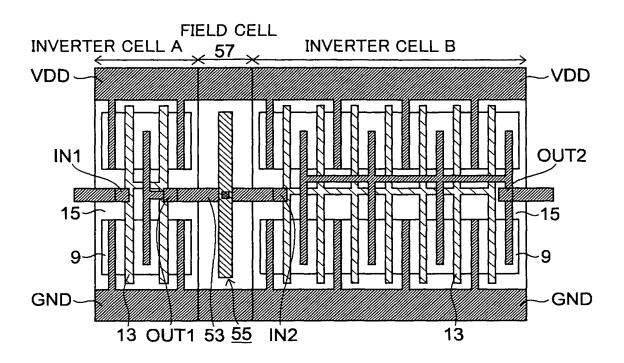
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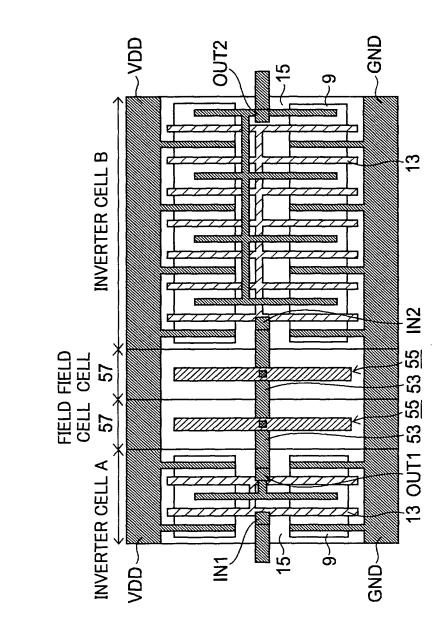


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FIG.8



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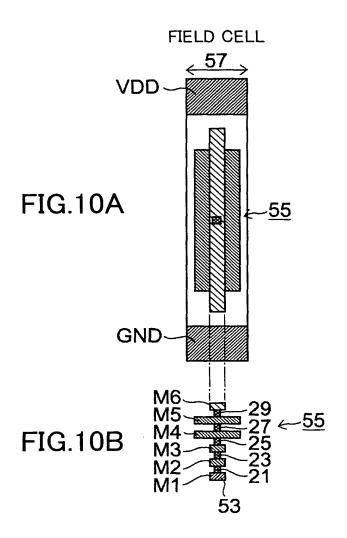


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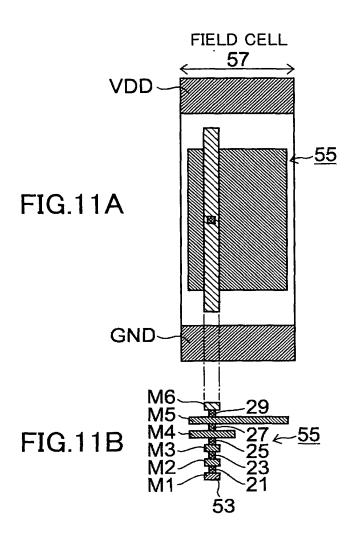
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FIG.12

